



7-9-04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: **MAIL STOP: AMENDMENT**

Norio KIMURA et al.

: **Confirmation No. 9675**

Serial No. 10/784,945

: Docket No. 2004\_0201

Filed February 25, 2004

: Group Art Unit 3723

POLISHING APPARATUS AND METHOD : Examiner E.P. MORGAN

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**AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

This is in response to the Restriction Requirement of September 8, 2004.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a method of surface and outer peripheral polishing by claims 1-5, 17 and 20.

Also, claims 21 and 22 have been added.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.